



ITW

Docket No.: SON-2010  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Hisao Hayashi et al.

Application No.: 09/772,986

Confirmation No.: 2637

Filed: January 31, 2001

Art Unit: 2895

For: THIN FILM SEMICONDUCTOR DEVICE  
AND MANUFACTURING METHOD  
THEREOF

Examiner: T. F. Tran

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the representative named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive a response to the Request for Rehearing filed November 20, 2009.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. SON-2010 from which the undersigned is authorized to draw.

Dated: February 18, 2010

Respectfully submitted,

By   
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